

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED TC 1700

In re PATENT application of:

Applicants: Kenneth Snowdon et al.

Serial No: 09/698,800

Filed:

October 27, 2000

Title:

GLASS FIBRE FIXATIVE AND FIXING PROCESS

Art Unit:

1731

Examiner: Michael Colaianni

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST (REVOCATION OF PRIOR POWERS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The assignee of the entire right, title and interest of the above identified patent application, hereby revokes all powers of attorney previously given and hereby appoints the following attorneys to prosecute and transact all business in the Patent and Trademark Office connected with the above referenced application.

Mark D. Saralino, Registration No. 34,243

Send correspondence and direct telephone calls to:

Mark D. Saralino, Esq. RENNER, OTTO, BOISSELLE & SKLAR 1621 Euclid Avenue, 19th Floor Cleveland, Ohio 44115

> Tel: 216-621-1113 Fax: 216-621-6165

The undersigned has reviewed all the documents in the chain of title of the patent application identified above and, to the best of the undersigned's knowledge and belief, title is in the assignee identified below.

A statement under 37 CFR 3.73(b) is submitted herewith.

The undersigned further declares that he is empowered to act on behalf of the assignee, and that all statements made herein of his own knowledge are true, and that all statements made on information and belief are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the like so made, are punishable by fine or imprisonment, or both, under Section 1001, Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

BOOKHAM TECHNOLOGY PLC

Intellectual Property Manager

Z:\SEC154\MDS\MARS\P145us\POA Revocation.wpd;POW-ASS.FRM (9/96)

Under the Paperwork Reseation Act of 1995

PTO/SB/96 (08-00)
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STATEMENT UNDER 37 CFR 3.73(b)

Linder the Paperwork Reportion Act of 1995, to persons are	required to respond to a collection of information unless it displays a valid OMB control number.	
& TRADE	Docket No.MARSP0145US	٥,
STATEM	ENT UNDER 37 CFR 3.73(b)	K)
Applicant/Patent Owner: Kenneth Snowd	on, et al.	
Applicant/Patent Owner: New 19/698 800	Filed/Issue Date: October 27, 2000	PROPINED TOO
Application No./Patent No.: 0970907000	ETYING PROCESS	300
Entitled: GLASS FIBRE FIXATIVE AND	Garagetion	0
BOOKHAM TECHNOLOGY PLC	a COPPORATION (Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)	90
(Name of Assignee)	(Type of Addignost Sign Salpassan)	
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states that it is:	and interest: Or	1
1. The assignee of the entire right, title, a		
2. an assignee of less than the entire right The extent (by, percentage) of its ow	nership interest is%	
in the patent application/patent identified at	pove by virtue of either:	
the inventor(s)	of the patent application/patent identified above. The assignment atent and Trademark Office at Reel, Frame, or for	
OR		
assignee as shown below:	of the patent application/patent identified above, to the current	
	n the United States Patent and Trademark Office at 0325, or for which a copy thereof is attached. To: BOOKHAM TECHNOLOGY PLC	
2 From Nortel Networks Co	orp. To: BOOKHAM TECHNOLOGY PLC	
The design of the property of i	n the United States Patent and Trademark Office at, or for which a copy thereof is attached.	
3. From:	To:	
The design of was recorded in	in the United States Patent and Trademark Office at, or for which a copy thereof is attached.	
[] Additional documents in the o	chain of title are listed on a supplemental sheet.	
must be submitted to Assignment Divisor recorded in the records of the USPTO.	sion in accordance with 37 CFR Part 3, if the assignment is to be . <u>See</u> MPEP 302.08]	
The undersigned (whose title is supplied b	elow) is authorized to act on behalf of the assignee.	
2 9,000	Haydn Jones	
Date	Typed or printed name Hayd- Signature	
	Intellectual Property Manager	
	Title	

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

AMENDMENT TO THE PATENT ASSIGNMENT AGREEMENT

This Amendment (this "Amendment"), effective as of November 8, 2002, to the Patent Assignment Agreement made on November 8, 2002 (the "PAA") is hereby made by and among NORTEL NETWORKS CORPORATION, a corporation duly incorporated under the laws of Canada, having its executive offices at 8200 Dixie Road, Suite 100, Brampton, Ontario L6T 5P6 Canada, and each of its subsidiaries that are listed on the signature pages hereto (collectively, the "Assigning Parties") and BOOKHAM TECHNOLOGY PLC, a public limited company incorporated under the laws of England and Wales having its executive offices at 90 Milton Park, Abingdon, Oxfordshire OX14, 4RY United Kingdom (the "Assignee") (each of the Assigning Parties and Assignee, a "Party" and, collectively, the "Parties").

WHEREAS, the Parties, having entered into the PAA, desire to amend the PAA to update the schedule of patents, patent applications and invention disclosures attached thereto.

NOW THEREFORE, in consideration of the foregoing premises and the mutual terms and conditions set forth herein, and for U.S. \$1.00 (ONE DOLLAR) and other good and valuable consideration, receipt and adequacy of which is hereby acknowledged, the Parties hereby agree that the PAA be, and is, amended as follows:

- 1. Schedule A of the PAA is deleted in its entirety and replaced with the new Schedule A attached hereto.
- 2. Except as expressly amended by this Amendment, all of the terms, covenants and conditions of the PAA shall remain unamended and in full force and effect.
- 3. This Amendment is hereby incorporated in, and forms a part of, the PAA. For the avoidance of doubt, this Amendment shall be governed by and enforced in accordance with the laws of the State of New York, without giving effect to any conflicts of law principles.
- 4. This Amendment shall be binding on, and shall inure to the benefit of, the Parties and their respective successors and assigns.
- 5. This Amendment may be executed in any number of counterparts, each of which shall be deemed to be an original but all of which shall constitute one and the same instrument.

[Remainder of page intentionally left blank]

IN WITNESS WHEREOF, the Parties have duly executed this Amendment as of the date first above written.

> NORTEL NETWORKS CORPORATION

Name: Khush Dadyburjor, as Attorney-in-

Fact

NORTEL NETWORKS

INCORPORATED

Name: Knush Dadyburjor, as Attorney-in-

Fact

NORTEL NETWORKS LIMITED

Name: Khush Dadyburjor, as Attorney-in-

Fact

NORTEL NETWORKS PROPERTIES

LIMITED

Name: Khush Dadyburjor, as Attorney-in-

Fact

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Name: Khush Dadyburjor, as Attorney-in-
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all States
Ву:
Name: Khush Dadyburjor, as Attorney-in-
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NORTEL NETWORKS OPTICAL COMPONENTS INCORPORATED By: Name: Khush Dadyburjor, as Attorney-in- Fact
NORTEL NETWORKS HPOCS INCORPORATED By: Name: Khush Dadyburjor, as Attorney-in- Fact
NORTEL NETWORKS PHOTONICS PTY LIMITED By: Name: Khush Dadyburjor, as Attorney-in- Fact
NORTEL NETWORKS SHANNON LIMITED By: Name: Khush Dadyburjor, as Attorney-in- Fact

BOOKHAM TECHNOLOGY PLC

By:___ Name: Title:

On this <u>On</u> day of December, 2002, before me appeared <u>Musical Auditorial</u>, the person who signed this instrument, who acknowledged that he/she signed it as a free act on his/her own behalf or on behalf of the Assigning Parties with authority to do so.

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(7.2)					

On this day of December, 2002, before me appeared who signed this instrument, who acknowledged that he/she si behalf or on behalf of Bookham Technology plc with authorit	gned it às a free act on his/her own
State of Kingland	
State of <u>Limited</u>) County of <u>Charles</u> State of <u>Similard</u> State of	
Hent Cemb.	
STUART P. B. CAPEL SOLICITOR & NOTARY PUBLIC 6 EAST SAINT HELEN STREET ABINGDON, OXON, OX14 5EW	
TEL: 01235 - 523411 FAX: 01235 - 533283	

SCHEDULE A

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No.					Status	S ADERLANDS AS	PHOTODETECTOR WITH
10289RO	PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY	CA	2,269,298				SPECTRALLY EXTENDED RESPONSIVITY
10289RO	PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY	US	09/294,114	6,222,200			PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY
10412RO	EXTERNAL CAVITY LASER	US	09/688,873				EXTERNAL CAVITY LASER USING ANGLE-TUNED FILTER AND METHOD OF MAKING SAME
10413ID	FIBRE TERMINATION COMPOUND GRADED INDEX LENSES	US	09/750,874				FIBRE TERMINATION COMPOUND GRADED INDEX LENSES
10485RO	ELECTRICALLY CONTROLLED OPTICAL ATTENUATOR WITH COPLANAR ELECTRODES	US	09/726,409				ELECTROCHROMIC OPTICAL ATTENUATOR ALIGNMENT METHOD FOR
10509RO	ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS	US	09/472,121	6,287,401			SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS ALIGNMENT METHOD FOR
10509RO	ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS	CA	2,328,279				SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS MODULATOR ASSEMBLIES
11006ID	MODULATOR ASSEMBLIES	US	09/496,917				
11920ID	PUMPED OPTICAL AMPLIFICATION DEVICE	us	09/557,891				PUMPED OPTICAL AMPLIFICATION DEVICE
11945ID	A RAMAN FIBRE LASER	us	09/573,238				A RAMAN FIBRE LASER
11954ID	A RAMAN FIBRE LASER	us	09/573,236				A RAMAN FIBRE LASER
12242RO	INVERTED INP/INGAAS AVALANCHE	US	09/733,060				EPITAXIALLY GROWN AVALANCHE PHOTODIODE
10000ID	PHOTODIODE OPTICAL FIBER DEVICE	us	09/653,985	+	 		OPTICAL FIBER DEVICE
12339ID 12349RO	COMPACT CHIP LABELING USING	CA	2,320,612				COMPACT CHIP LABELING USING STEPPER TECHNOLOGY
12349RO	STEPPER TECHNOLOGY. COMPACT CHIP LABELING USING STEPPER TECHNOLOGY.	US	09/688,366				COMPACT CHIP LABELING USING STEPPER TECHNOLOGY
12526RC		US	09/660,542	6,409,241			APPARATUS FOR GRIPPING CERAMIC SUBSTRATES PACKAGING ATMOSPHERE AND
12615ID	PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE	US	09/676,256				METHOD OF PACKAGING A MEMS DEVICE
12634RC	0.50	us	09/741,350				STRUCTURE AND METHOD FOR DOPING OF III-V COMPOUNDS
12665R0	PRINT QUALITY TEST STRUCTURE FOR DEVIC MANUFACTURING.	US	09/667,620				PRINT QUALITY TEST STRUCTURE FOR LITHOGRAPHIC DEVICE MANUFACTURING GLASS FIBER FIXATIVE AND
126861	GLASS FIBER FIXATIVE AND FIXING PROCESS	US	09/698,800				FIXING PROCESS METHODS FOR MAKING
12715R0		US	09/667,622				PATTERNS IN RADIATION SENSITIVE POLYMERS

and see a	MEDISCIOSUFE TALLE	Giv	Serial No.	PatentiNo	SUD	Alinyenios vili Laik Nos	Application wile
No				5.930,441	Status		SPLIT-BEAM FOURIER FILTER
12800AU	SPLIT-BEAM FOURIER FILTER	US	08/793,729	5,930,441			INTEGRATED OPTICAL
12841ID	INTEGRATED OPTICAL TRANSMITTER	US	09/616,659				TRANSMITTER CONFINEMENT LAYER OF
12847RO	BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER	CA	2,328,641				BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
12847RO	BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER	US	10/014,807				CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
12849ID	OPTICAL AMPLIFIER METHOD AND APPARATUS	US	09/710,372				OPTICAL AMPLIFIER METHOD AND APPARATUS
12849ID	OPTICAL AMPLIFIER METHOD AND APPARATUS	WO F	CT/GB01/04944				OPTICAL AMPLIFIER METHOD AND APPARATUS
12948ID	OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE	υs	09/731,434				OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE
12948ID	OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE	CA	2,364,383				OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE
13063CK	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH	US	08/726,049	6,041,071			ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER
13063CK	AGILE, WIDELY TUNABLE	US	60/004,620				AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH
13063CK	NARROW LINEWIDTH AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH	US	09/532,529				ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER
13144CK	LASER WITH SETTABLE WAVELENGTHS	US	0		Mailed Application	TAYEBATI, PARVIZ (7043-5010439), VAKHSHOORI, DARYOOSH (7068- 5010442)	LASER WITH SETTABLE WAVELENGTHS
13144CK	LASER WITH SETTABLE	US	60/099,252	 			LASER WITH SETTABLE WAVELENGTHS
13144CH	WAVELENGTHS LASER WITH SETTABLE	US	60/099,308				LASER WITH SETTABLE WAVELENGTHS
13144Ck	WAVELENGTHS LASER WITH SETTABLE	US	09/386,604		 		LASER WITH SETTABLE WAVELENGTHS
13144CF	WAVELENGTHS LASER WITH SETTABLE	CA	2,317,133				LASER WITH SETTABLE WAVELENGTHS
	WAVELENGTHS (SINGLE ETALON OPTICA WAVELENGTH	1	60/148,017				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	REFERENCE DEVICE K SINGLE ETALON OPTICA WAVELENGTH REFERENCE DEVICE	Į.	09/636,817		N. All Div		SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE SINGLE ETALON OPTICAL
	K SINGLE ETALON OPTICA WAVELENGTH REFERENCE DEVICE	_i		04	Nat'l Phas Filed	e e	WAVELENGTH REFERENCE DEVICE SINGLE ETALON OPTICAL
1	K SINGLE ETALON OPTICA WAVELENGTH REFERENCE DEVICE						WAVELENGTH REFERENCE DEVICE SINGLE ETALON OPTICAL
13199C	K SINGLE ETALON OPTICA WAVELENGTH REFERENCE DEVICE	AL EP	973357.7				WAVELENGTH REFERENCE DEVICE

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No. 13201CK	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	US	60/148,148				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201CK	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	WOF	PCT/US00/21905		Nat'i Phase Filed		DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201CK	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	US	09/636,807				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201CK	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	CA	2,381,665				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201CK	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	EP	00957375.9				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13391RO	MONOLITHICALLY INTEGRATED OPTICALLY PUMPED EDGE EMITTING SEMICONDUCTOR LASER	US	09/987,785				MONOLITHICALLY INTEGRATED OPTICALLY-PUMPED EDGE- EMITTING SEMICONDUCTOR LASER METHOD OF ETCHING
13417RO	GRATING ETCHING WITH INP MASKING	US	09/750,124				PATTERNS INTO EPITAXIAL MATERIAL MICROELATION FOR DWDM
13444CK	MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS	US	09/859,938				TELECOMMUNICATIONS APPLICATIONS MICROELATION FOR DWDM
13444CK		wo	PCT/US01/14918				TELECOMMUNICATIONS APPLICATIONS METHOD AND APPARATUS FOR
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	US	09/821,580				MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS METHOD AND APPARATUS FOR
13494ID	100 110	EP	02251194.3				MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS METHOD AND APPARATUS FOR
13494ID	100 410	CA	2,374,557				MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS OPTICAL MODULATORS
13495ID		US	09/679,165	6,377,717		<u> </u>	OPTICAL FIBER TERMINATION
13502R0	DALL TO STEEL TO DALL	US	09/735,571				A METHOD AND SYSTEM FOR
13524R0	THE PROPERTY OF THE PARTY OF TH	US	10/196,956				FABRICATING SEMICONDUCTOR LASERS SEMICONDUCTOR LASER
13544R	TOTOD.	us	10/141,914				ELECTRODE TERMINATION FOR
13584R		US	09/709,646				REDUCED LOCAL HEATING IN AN OPTICAL DEVICE ELECTRODE TERMINATION FOR
13584R		CA	2,361,683				REDUCED LOCAL HEATING IN AN OPTICAL DEVICE ELECTRODE TERMINATION FOR
13584P		EP	01309541.9				REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13591		S GE	0031241.3				OF HOAL MODULATORS

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	OPTICAL MODULATORS	3	TERM TERMINET		Status	panelos -	OPTICAL MODULATOR
13614ID	OPTICAL PULSE	US	09/993,849				OPTICAL PULSE GENERATION
13614ID	GENERATION OPTICAL PULSE	wo	PCT/GB02/03664				OPTICAL PULSE GENERATION
13721RO	GENERATION AN NON-DESTRUCTIVE	us	0		Mailed Application	QIAN, YAHONG (C115-0531819,1), AN,	AN NON-DESTRUCTIVE AND FAST WAY TO DETECT
	AND FAST WAY TO DETECT DIFFUSION DEPTH AND UNIFORMITY CROSS A WAFER				Application	SERGUEI (5C33- 0510038,1)	DIFFUSION DEPTH AD UNIFORMITY CROSS A WAFER MONOLITHICALLY INTEGRATED
13813RO	HIGH POWER LASER DIODE AND METHOD OF FABRICATION THEREOF	US	10/141,862				HIGH POWER LASER OPTICAL DEVICE
13816RO					Unfiled		ISOLATION OF MICROWAVE
14224ID	ISOLATION OF MICROWAVE TRANSMISSION LINES	US	10/032,416				TRANSMISSION LINES HYBRID CONFINEMENT LAYERS
14404RO	THE PARTY OF A STATE AND A STA	US	10/027,229				OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER OPTICAL BEAM SAMPLING
14429ID	OPTICAL BEAM SAMPLING MONITOR	US	10/006,509				MONITOR A TITANIUM NITRIDE DIFFUSION
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	CA	2,292,769				BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD A TITANIUM NITRIDE DIFFUSION
14433JD		EP	99919257.8				BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD		JP	11-552490				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD TITANIUM NITRIDE DIFFUSION
14433JD	DITTANIUM NITRIDE DIFFUSION BARRIER FOF USE IN NON-SILICON TECHNOLOGIES AND METHOD	US	09/063,173	6,204,560			BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METHOD
14433JE	The state of the s	2	10-1999-7012042				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD A TITANIUM NITRIDE DIFFUSION
14433JI	DITTANIUM NITRIDE DIFFUSION BARRIER FOI USE IN NON-SILICON TECHNOLOGIES AND METHOD		PCT/EP99/02665		Nat'l Phase Filed	3	BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD

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1433JD D	TITANIUM NITRIDE IFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	JP	0			DAETWYLER, ANDREAS (- GPS4097856), DEUTSCH, URS (EXTR-GPS4097859), HARDER, CHRISTOPH (AA54-5050202), HEUBERGER, WILHELM (EXTR-GPS4097866), LATTA, ERNST-EBERHARD (EXTR-GPS4097878), JAKUBOWICZ, ABRAM (-GPS4097872), OOSENBRUG, ALBERTUS (- GPS4097875)	A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
4434JD	STABILIZED LASER	EP	99810837.7			<u> </u>	STABILIZED LASER SOURCE
4434JD	SOURCE STABILIZED LASER SOURCE	us	10/049,886				STABILIZED LASER SOURCE SUPPORTING STRUCTURE FOR
4435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	EΡ	99811030.8				FIBER FIXING AND SUBMICRON FINE ALIGNMENT SUPPORTING STRUCTURE FOR
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	wo	PCT/IB00/01530		Nat'l Phase Filed		OPTICAL FIBER FIXING AND SUBMICRONFINE ALIGNMENT SUPPORTING STRUCTURE FOR
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	US	PCT/IB00/01530		Nat'l Phase Filed		FIBER FIXING AND SUBMICRON FINE ALIGNMENT SUPPORTING STRUCTURE FOR
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	CA	2,390,916		Nat'l Phase Filed		FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14480RO	GAIN COUPLED DISTRIBUTED FEEDBACK LASER USING SELF- ASSEMBLED QUANTUM DOTS				Unfiled		HIGH POWER SEMICONDUCTOR
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	บร	09/852,994	_			LASER DIODE HIGH POWER SEMICONDUCTOR
14549JD	HIGH POWER SEMICONDUCTOR LASEF DIODE	CA	2,385,653				LASER DIODE HIGH POWER SEMICONDUCTOR
14549JD		EP	2405380.3				LASER DIODE
14549JD	HIGH POWER SEMICONDUCTOR LASE	JP	2002-134066				HIGH POWER SEMICONDUCTOR LASER DIODE
14551JD	DIODE CARRIER DESIGN FOR MODULES WITH HIGH POWER LASER DIODES	US	10/026,150				HIGH POWER LASER CARRIER ANTI-REFLECTION COATINGS
14552JD	DEST FORM	US	09/993,824				FOR SEMICONDUCTOR LASERS
1459210		E US	10/024,972				ALIGNMENT ASSEMBLY FOR A SENSITIVE OPTICAL ALIGNMEN ENHANCED LINK OPERATION O
14676R0	ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN- COUPLED GRATINGS) U	60/334,013				DIRECTLY MODULATED LASER USING GAIN-COUPLED GRATINGS

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4676RO	ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN- COUPLED GRATINGS	US	10/025,866				ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS COUPLED-COUPLED GRATINGS
4681ID	THERMAL COMPENSATION AND ALIGNMENT FOR OPTICAL DEVICES	US	10/032,421				ALIGNMENT FOR OPTICAL DEVICES
4716RO	WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS	us	10/073,101				WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS METHOD AND APPARATUS FOR
4794RO	A METHOD FOR MAKING FLOATING GRATINGS	US	10/259,745				FLOATING GRATINGS IN DFB (DISTRIBUTED FEEDBACK) LASERS
14854RO	A METHOD FOR MINIMIZING CROSSTALK DUE TO LASER WAVELENGTH VARIATIONS WITH NON- IDEAL FILTERS				Unfiled		CURRENT TUNED MACH-
14864RO	POLARIZATION AND WAVELENGTH INDEPENDENT MHZ SPEED OPTICAL ATTENUATOR	บร	10/190,592				ZEHNDER OPTICAL ATTENUATOR RE-CIRCULATING OPTICAL
14942RO		บร	10/116,168				PULSE GENERATOR MICRO-MIRRORS WITH
15004RO	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)	US	10/098,446				VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS
15004RO	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)	US	10/098,446				MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPO ENTS COMPRISING MICRO-MIRRORS
15004RC	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)	US	10/098,446				MICRO-MIRRORS WITH VARIABLE FOCAL LENGTH, AND OPTICAL COMPONENTS COMPRISING MICRO-MIRRORS
15093RC	MULTIPLE-CONTACT SEMICONDUCTOR OPTICAL AMPLIFIERS	US	60/414,404				MULTIPLE-CONTACT OPTICAL AMPLIFIERS FREQUENCY IDENTIFICATION
15095R0		US	10/108,856				WITH FREQUENCY LOCKER WAVELENGTH STABILIZED
15113CI	METHOD TO IMPROVE TEMPERATURE STABILITY OF FREQUENCY LOCKER IN OPTOELECTRONIC	US	10/165,465				OPTICAL DEVICE
15116	MODULES D NEW STRAIGHT-FLARED STRAIGHT WAVEGUIDE	- US	10/131,335				HIGH POWER SEMICONDUCTO LASER DIODE AND METHOD FO MAKING SUCH A DIODE
15117J	I WITH IMPROVED	us	0				*PUMP LASER DIODE WITH IMPROVED WAVELENGTH STABILITY
15138	WAVELENGTH STABILIT D AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICAL COMPONENT	US	10/161,523				AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICA COMPONENT

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	SINGLE MODE, HIGH INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES	US	60/352,572				WAVEGUIDES FOR OPTICAL WIRE BONDS
	SINGLE MODE, HIGH INDEX CONTRAST POLYMER FLEXIBLE	US	60/352,572				WAVEGUIDES FOR OPTICAL WIRE BONDS METHOD FOR INTEGRATING
150RO II	WAVEGUIDES METHOD FOR NTEGRATING A LASER JITH A WAVEGUIDE IN A SINGLE EPITAXIAL GROWTH STEP	US	0		Mailed Application	(5C33-0519/25), GREENSPAN, JONATHAN (C116- 0262541)	OPTICAL DEVICES IN A SINGLE EPITAXIAGROWTH STEP METHOD FOR INTEGRATING
150RO	METHOD FOR INTEGRATING A LASER VITH A WAVEGUIDE IN A SINGLE EPITAXIAL GROWTH STEP	US	0		Mailed Application	GLEW, RICK (C116- 2819324), BETTY, IAN (5C33-0519725), GREENSPAN, JONATHAN (C116- 0262541)	OPTICAL DEVICES IN A SINGLE EPITAXIAGROWTH STEP
5164RO	A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF- ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER.	US	0		Mailed Application	0531388), LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053588)	A GUIDED SELF-ALIGNED LASEF STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
5164RO	A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF- ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER.	US	0		Mailed Application	GLEW, RICK (C116- 2819324), REID, BENOIT (5C32- 0531388), LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568)	A GUIDED SELF-ALIGNED LASE STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
		US	60/391,648	 			LASER TRANSMITTER
15181ID	LASER TRANSMITTER				-		LASER TRANSMITTER OPTIMIZED PERFORMANCE O
15181ID 15193RO	INGAASP/INP COMPAC ON-CHIP POLARIZATION	US T					INGAASP/INP COMPACT ON-CI- POLARIATION CONVERTER
15193RO	CONVERTER	US T	3		Mailed Application	JONES, TREVOR (C115-1342592,2), YEVICK, D (EXTR GPS0380642,2)	POLARIATION CONVERTER
15320RC			0		Mailed Application	on (5C33-0526051), BETTY, IAN (5C33 0519725)	WITH CONTINUOUSLY
15338R	DISTRIBUTED FEEDBA LASER	CK			Unfiled	TRAUT SILKE (42'	12- HIGH POWER SEMICONDUCT
15386Ji	T THE STREET	1 1	0		Applicati	5050415), SCHMID BERTHOLD (AAS- 5050359,4), SVERDLOV, BOR (AA54-5050400,1 THIES, ACHIM (42 5050409,1)	MAKING SUCH A DIODE
15389	ID LASER STABILIZATION USING VERY HIGH RELATIVE FEEDBA	1 [Unfile	d	

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No. 390RO	ON-CHIP POLARIZATION SPLITTER/COMBINER	US	60/404,166				ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE
390RO	DEVICE ON-CHIP POLARIZATION	US	60/404,166				ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE
2000 10	SPLITTER/COMBINER DEVICE A GUIDED SELF-ALIGNED	US	60/390,882				A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL
33930	LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER					LICHTENSTEIN,	CURRENT BLOCKING LAYER A GUIDED SELF-ALIGNED LASER
5399JD	A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER	US			Mailed Application	NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568,1), SCHMIDT, BERTHOLD (AA54- 5050359,2), REID, BENOIT (5C32- 0531388,2), KNIGHT, D. GORDON (C116- 1529664,1)	STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
5502RO	A P-SUBSTRATE SELF-	-			Unfiled		
5502110	ALIGNED LASER STRUCTURE WITH IRON DOPED CURRENT BLOCKING LAYERS						
5507RO	DOTES OF THE				Unfiled		
	WAVEGUIDE TE/TM MODE CONVERTER IN SEMICONDUCTING MATERIALS						
15558RC	MANUFACTURE OF A GRATING TEMPLATE ANI ITS TRANSFER INTO AL (IN, GA)AS MATERIAL USING IN-SITU ETCHING AND REGROWTH INSIDE A GROWTH REACTOR.	4			Unfiled		
15592R0	D ETCHING OF INDEX- OF GAIN-COUPLED GRATINGS INTO INGASP MATERIAL USING IN-SITU ETCHING IN A GROWTH REACTO	3					
15649JI	LASER STRUCTURE WIT LARGE OPTICAL SUPERLATTICE WAVEGUIDE	H			Unfiled		
15655R	O HIGH TEMPERATURE OPERATION LASER DIODES				Unfiled		
15656R	THE STREET A	SPI			unfiled		SUPERIMPOSED GRATING WDI
HQ005			A 2,228,683	2,228,683	3		TUNABLE LASERS SUPERIMPOSED GRATING WD
HQ005	SUPERIMPOSED GRATING WDM TUNAB LASERS		09/253,129	6,141,37	0		TUNABLE LASERS

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No D0032	OPTO ELECTRONIC COMPONENTS	US	第二次 1000 1000 1000 1000 1000 1000 1000 10	5,534,442			OPTO ELECTRONIC COMPONENTS
ID0079	SEMICONDUCTOR -	GB	9216363.3	2 269 268			SEMICONDUCTOR - SLICE CLEAVING
10075	SLICE CLEAVING		08/093,766	5,393,707			SEMICONDUCTOR - SLICE
ID0079	SEMICONDUCTOR - SLICE CLEAVING	US	08/093,700	5,550,70			CLEAVING HYBRID OPTIC SOLUTION
	HYBRID OPTIC SOLUTION	}]_	95307824.3	695 04 280.7			HYBRID OPTIC SOLUTION
	HYBRID OPTIC SOLUTION	1 1	95307824.3	0 713 271			HYBRID OPTIC SOLUTION
	HYBRID OPTIC SOLUTION	1 1	9423282.4	2 293 203			HYBRID OPTIC SOLUTION
	HYBRID OPTIC SOLUTION	1 1	08/560,312	5,668,823			HYBRID OPTIC SOLUTION
	HYBRID OPTIC SOLUTION SEMICONDUCTOR	FR	94301114.8	0 614 214			SEMICONDUCTOR ETCHING PROCESS
ID0134	ETCHING PROCESS						SEMICONDUCTOR ETCHING
ID0134	SEMICONDUCTOR ETCHING PROCESS	GB	94301114.8	0 614 214			PROCESS
1D0134	SEMICONDUCTOR ETCHING PROCESS	DE	69401370.6	69401370.6			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR	GB	9303257.1	2 275 364			SEMICONDUCTOR ETCHING PROCESS
	ETCHING PROCESS	JP	6-45068				SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	J					SEMICONDUCTOR ETCHING
ID0134	SEMICONDUCTOR ETCHING PROCESS	US	08/197,071	5,419,804			PROCESS
ID0137	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS	GB	9417975.1	2 293 248			PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS
ID013	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS	US S	08/507,613	5,574,811			PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS
ID017	AND AND		08/201,473	5,365,534			INJECTION LASER AND PHOTOSENSOR ASSEMBLY
ID019	3 FILAMENT COOLER	GB	9404290.0	2 287 244			FILAMENT COOLER
ID019	3 FILAMENT COOLER	us	08/388,151	5,568,728			FILAMENT COOLER CO & COUNTER-PUMPED
ID019	OPTICAL AMPLIFIER	ED US	08/303,367	5,542,011			OPTICAL AMPLIFIER
1D020	DE ELECTRO ABSORPTIO OPTICAL MODULATOR	N US	08/303,374	5,530,580			ELECTRO ABSORPTION OPTICAL MODULATORS
1D02		ON EF	94306216.6	0 643 317	Nat'l Phas Filed	se	ELECTRO ABSORPTION OPTICA MODULATORS ELECTRO ABSORPTION OPTICA
1D02	06 ELECTRO ABSORPTIO OPTICAL MODULATOR	ON GI	B 9417001.6	2 281 785			MODULATORS

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No 2006 E		DE	94306216.6	694 26 796.1		ELECTRO ABSORPTION OPTICAL MODULATORS
ł	OPTICAL MODULATORS		04206216.6	0 643 317		ELECTRO ABSORPTION OPTICAL
0206 E	DETICAL MODULATORS	FR	94306216.6	00.30		MODULATORS
00206 E	LECTRO ABSORPTION	JP	216309/94			ELECTRO ABSORPTION OPTICAL MODULATORS
10	OPTICAL MODULATORS	l_				PROVIDING OPTICAL COUPLING
	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	DE	94305060.9	694 10 032.3		WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
		FR	94305060.9	0 636 912		PROVIDING OPTICAL COUPLING
00216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS		94303000.3			WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCER
	PROVIDING OPTICAL	GB	9315789.9	2 280 544		PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL
D0216	COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS					SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCER
		GB	94305060.9	0 636 912		PROVIDING OPTICAL COUPLIN WITH SINGLE CRYSTAL
D0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	GB	34303000.3			SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCER
	_		180288/94			PROVIDING OPTICAL COUPLING
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	JP	180200/34			WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCEI
		US	08/283,264	5,522,000		PROVIDING OPTICAL COUPLIN WITH SINGLE CRYSTAL
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS		00/200,20			SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCE
10.000	DIRECT AMPLITUDE	US	08/216,301	5,502,741		DIRECT AMPLITUDE MODULATION OF LASERS
ID0237	MODULATION OF LASERS	S				HADDOVENENTS IN CRYSTA
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	EP	96301377.6	0 732 739	Nat'l Phase Filed	SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN	JP	52013/96			IMPROVEMENTS IN CRYSTA SUBSTRATE PROCESSING
الاعتابا	CRYSTAL SUBSTRATE PROCESSING					
ID0261	IMPROVEMENTS IN	US	08/612,314	5,933,707		IMPROVEMENTS IN CRYSTA SUBSTRATE PROCESSING
100201	CRYSTAL SUBSTRATE PROCESSING					
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	GE	96301377.6	0 732 739		IMPROVEMENTS IN CRYSTA SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE	DE	96301377.6	696 18 264.5		IMPROVEMENTS IN CRYSTA SUBSTRATE PROCESSING

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D0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	FR	96301377.6 0	732 739		170	SUBSTRATE PROCESSING
00287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	DE	195 28 165.9				POLARISATION-INSENSITIVE OPTICAL MODULATORS
00287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	GB	9515400.1 2	291 979			POLARISATION-INSENSITIVE OPTICAL MODULATORS
D0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	FR	9509417	2723485			POLARISATION-INSENSITIVE OPTICAL MODULATORS
D0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	us	08/510,752	5,275,321			POLARISATION-INSENSITIVE OPTICAL MODULATORS
D0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	EP	95308872.1	717 297	Vat'l Phase Filed		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	GB	9425022.2	2 296 101			OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	US	08/570,983	5,570,444			OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	DE	95308872.1	695 26 563.6			OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	GB	95308872.1	0 717 297			OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	FR	95308872.1	0 717 297			OPTICALLY COUPLING OPTICA FIBRES TO INJECTION LASERS
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	iπ	95308872.1	0 717 297			OPTICALLY COUPLING OPTICA FIBRES TO INJECTION LASERS
ID0311	OPTICAL AMPLIFIER	DE	96308900.8	696 03 935.4			OPTICAL AMPLIFIER
ID0311	OPTICAL AMPLIFIER	EP	96308900.8		Nat'l Phase Filed		OPTICAL AMPLIFIER
ID0311	AND FIED	IT	96308900.8	0 779 689			OPTICAL AMPLIFIER
ID0311	· · · · · · · · · · · · · · · · · · ·	FR	96308900.8	0 779 689			OPTICAL AMPLIFIER
ID0311	ALADI ITIED	GB	9525766.3	2 308 222			OPTICAL AMPLIFIER
1D031		US	08/760,175	5,872,649			OPTICAL AMPLIFIER
ID034		EB	PCT/GB96/01406	-	Nat'i Phase	Э	LASERS
1D038	0.001	GB	9515004.1	2 303 467			HERMETIC OPTICAL FIBRE FEI
ID038	4 HERMETIC OPTICAL FIBRE FEED-THROUGH	US	08/684,128	5,664,043			HERMETIC OPTICAL FIBRE FEE THROUGH

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		EP	97305110.5		Siaus		ETALON ARRANGEMENT
	ETALON ARRANGEMENT	JP	179766/1997				ETALON ARRANGEMENT
	ETALON ARRANGEMENT	JP	179766/1997				ETALON ARRANGEMENT
D0426			2,203,845	2,203,845			ETALON ARRANGEMENT
D0426	ETALON ARRANGEMENT	CA		5,828,689			ETALON ARRANGEMENT
D0426	ETALON ARRANGEMENT	us	08/848,337				SEMICONDUCTOR LASERS
D0431	SEMICONDUCTOR LASERS	DE	97901693.8	697 00 830.4			
D0431	SEMICONDUCTOR LASERS	EΡ	97901693.8	0 876 696	Nat'l Phase Filed		SEMICONDUCTOR LASERS
D0431	SEMICONDUCTOR LASERS	FR	97901693.8	0 876 696			SEMICONDUCTOR LASERS
D0431	SEMICONDUCTOR LASERS	GB	9601703.3	2 309 581			SEMICONDUCTOR LASERS
D0431	SEMICONDUCTOR LASERS	GB	97901693.8	0 876 696			SEMICONDUCTOR LASERS
D0431	SEMICONDUCTOR LASERS	IT	97901693.8	0 876 696			SEMICONDUCTOR LASERS
D0431	SEMICONDUCTOR LASERS	JP	526680/1997				SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	US	09/091,684	6,058,125			SEMICONDUCTOR LASERS
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	EP	97902473.4	0 879 435	Nat'l Phase Filed		SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	GB	9602564.8	2 310 052			CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	JP	528272/1997				CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSI OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	US	08/952,676	5,985,086			CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
1D0467	7 CONTROLLED DISPENS OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	E DE	97902473.4	697 10 047.2			SECURING AN OPTICAL FIBRE I A V-GROOVE
ID046	7 CONTROLLED DISPENS OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	EIT	97902473.4	0 879 435	5		SECURING AN OPTICAL FIBRE A V-GROOVE

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0467 C	ONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	FR	97902473.4	0 879 435			A V-GROOVE
0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	W O F	PCT/GB97/00320		Nat'l Phase Filed		CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	JP	507707/1998				SEMICONDUCTOR PHOTODETECTOR PACKAGING
0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	US	09/214,634	6,188,118			SEMICONDUCTOR PHOTODETECTOR PACKAGING
0519	SEMICONDUCTOR PHOTODETECTOR	CA	2,258,178				SEMICONDUCTOR PHOTODETECTOR PACKAGING
00519	PACKAGING SEMICONDUCTOR PHOTODETECTOR PACKAGING	EP	97933796.1				SEMICONDUCTOR PHOTODETECTOR PACKAGING
00519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	wo	PCT/GB97/0205	3	Nat'l Phase Filed		SEMICONDUCTOR PHOTODETECTOR PACKAGING
0651	DIRECT AMPLITUDE MODULATION OF LASER	SEP	98303274.9				DIRECT AMPLITUDE MODULATION OF LASERS
DOSE1	DIRECT AMPLITUDE MODULATION OF LASER	US	08/865,760	5,901,164			DIRECT AMPLITUDE MODULATION OF LASERS DIRECT AMPLITUDE
D0651	DIRECT AMPLITUDE MODULATION OF LASER	CA	2,235,179				MODULATION OF LASERS DIRECT AMPLITUDE
D0651	DIRECT AMPLITUDE MODULATION OF LASER	JP RS	146072/1998				MODULATION OF LASERS OPTICAL TRANSMITTER OUTPL
D0687	OPTICAL TRANSMITTE OUTPUT MONITORING TAP	R US	08/984,894	6,124,956	5		MONITORING TAP
ID0691	BONDING RIDGE STRUCTURE LASER DIODES TO SUBSTRATI	US ES	09/072,810	6,075,800			BONDING RIDGE STRUCTURI LASER DIODES TO SUBSTRATI , REMOVABLY COATED OPTICA
ID0764	A REMOVABLY COATE OPTICAL FIBRE	D U	99/374,807	6,351,58	9		FIBRE FIBRE FIBRE
ID0803	TI FOTDICALLY	AL EI	98309206.5				OPTICAL ATTENUATOR
ID0803	B ELECTRICALLY CONTROLLABLE OPTIC ATTENUATOR	CAL	P 365470/1998	3			OPTICAL ATTENUATOR
ID080	3 ELECTRICALLY CONTROLLABLE OPTIC ATTENUATOR		S 08/997,752	5,956,43	37		ELECTRICALLY CONTROLLAR OPTICAL ATTENUATOR
ID080	3 ELECTRICALLY CONTROLLABLE OPTI		A 2,254,148				ELECTRICALLY CONTROLLAE OPTICAL ATTENUATOR

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D0908	SEMICONDUCTOR OPTO ELECTRONIC DEVICE PACKAGING	US	09/070,899	6,407,438			PACKAGING
D1107	MACH ZENDER	EP	00301124.4				INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES
D1107	STRUCTURES INTEGRATED OPTICAL MACH ZENDER STRUCTURES	us	09/280,360	6,240,221			INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES INTEGRATED OPTICAL MACH
ID1107		CA	2,299,794				ZEHNDER STRUCTURES INJECTION LASER PACKAGES
ID8512	INJECTION LASER PACKAGES	us	06/514,066	4,615,031			INJECTION LASER PACKAGES
ID8512	INJECTION LASER PACKAGES	GB	8317959	2 124 402			OPTICAL AMPLIFIERS
ID8850	OPTICAL AMPLIFIERS	us	06/888,274	4,720,684			
ID8850	OPTICAL AMPLIFIERS	CA	469,211	1,245,328			OPTICAL AMPLIFIERS
ID8852	MANUFACTURING OPTICAL FIBRE	US	06/736,327	4,608,276			MANUFACTURING OPTICAL FIBRE
ID8852	MANUFACTURING OPTICAL FIBRE	CA	482,229	1,261,632			MANUFACTURING OPTICAL FIBRE
ID8960	OPTICAL FIBRE MANUFACTURE	us	06/940,232	4,735,648			OPTICAL FIBRE MANUFACTURE
ID9003	COATING OPTICAL FIBRES	DE	85306977.1	356 83 25.2			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	JP	222908/85	2029150			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	บร	06/782,930	4,631,078			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	GB	85306977.1	0 178 107			COATING OPTICAL FIBRES
1D9003	COATING OPTICAL FIBRES	CA	492,574	1,226,411			COATING OPTICAL FIBRES
ID9186	LASER MANUFACTURE	US	07/296,946	4,949,352	-		LASER MANUFACTURE
ID9186	TO A A A H I TO A OTHER	GB	8512321	2 175 442			LASER MANUFACTURE
	THE SUBMOS	US	06/858,617	4,748,307			TUBE FURNACE
ID9209	- FIRE	US	06/896,518	4,793,840	 		OPTICAL FIBRE MANUFACTURE
ID9312	MANUFACTURE			<u> </u>			OPTICAL FIBRE MANUFACTURE
ID9312	OPTICAL FIBRE MANUFACTURE	GB	8520945	2 179 339			OPTICAL FIBRE CABLE HAVING
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	DE	365 02 56.1	365 02 56.	1		SLOTTED CORE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	FR	86306868.0	0 216 548			OPTICAL FIBRE CABLE HAVING SLOTTED CORE

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ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	GB	86306868.0	0 210 540		SLOTTED CORE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	NZ	217514	217514		OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	US	07/636,902	RE34,516		OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID9379	OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER	US	06/934,440	4,772,086		OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER
ID9379	OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER	GB	8530797	2 184 255		OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER
ID9495	LASER ARRAY	DE	87302417.8	376 44 10.6		LASER ARRAY
ID9495	LASER ARRAY	JP	129591/87	2511969		LASER ARRAY
ID9495	LASER ARRAY	us	07/032,779	4,760,580		LASER ARRAY
ID9552	OPTICAL FIBRE CABLES	DE	3883556.8	3883556.8		OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES	FR	88300817.9	0 278 648		OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES	GB	8703255	2 201 008		OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES	υs	07/154,866	4,830,459		OPTICAL FIBRE CABLES
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	DE	88306994.0	388 13 01.7		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	FR	88306994.0	0 304 182		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	GB	8719590	2 208 944		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	GB	88306994.0	0 304 182		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	NL	88306994.0	0 304 182		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	SE	88306994.0	0 304 182		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	US	07/230,057	4,988,159		FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9617	EDGE EMITTING LIGHT EMISSIVE DIODE	US	07/239,403	4,937,638		EDGE EMITTING LIGHT EMISSIVE DIODE
ID9661	WAVEGUIDE TO OPTO- ELECTRONIC TRANSDUCER	GB	8823873.8	2 213 957		WAVEGUIDE TO OPTO- ELECTRONIC TRANSDUCER

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ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	DE	690 20 050.1	690 20 050.1			CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	FR	90305474.0	0 400 853			CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	GB	8912458.0	2 232 260			CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	JP	141220/1990	2991238			CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	US	07/531,791	5,083,090			CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PERUNIT LENGTH
ID9716	CARB ON COATING OF OPTICAL FIBRES	DE	690 10 282.8	0 400 938			CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	FR	90305776.8	0 400 938			CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	GB	9011933.0	2 236 331			CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	JP	141221/1990	2866707			CARB ON COATING OF OPTICAL FIBRES
ID9716	CARB ON COATING OF OPTICAL FIBRES	US	07/531,859	5,062,687			CARB ON COATING OF OPTICAL FIBRES
ID9731	BONDING A SEMICONDUCTOR TO A SUBSTRATE	GB	8818522.8	2 221 570			BONDING A SEMICONDUCTOR TO A SUBSTRATE
ID9742	OPTICAL FILTERS	GB	8823078.4	2 223 324			OPTICAL FILTERS
ID9750	DIFFRACTION GRATING	DE	68928711.9	0365125			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	FR	89308702.3	0 365 125			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	GB	8821898.7	2 222 891			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	IT	22874/BE/98	0 365 125			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	us	07/579,081	5,029,981			DIFFRACTION GRATING

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ID9750	DIFFRACTION GRATING	JP	239789/1989	2005000			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608			DIFFRACTION GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608			
ID9750	DIFFRACTION GRATING	NL	89308702.3	0 365 125			DIFFRACTION GRATING
ID9752	VAPOUR PHASE PROCESSING	GB	8823233.5	2 223 509			VAPOUR PHASE PROCESSING
ID9763	MULTICHANNEL CAVITY LASER	DE	89312024.6	689 18 238.4		·	MULTICHANNEL CAVITY LASER
ID9763	MULTICHANNEL CAVITY LASER	FR	89312024.6	0 370 739			MULTICHANNEL CAVITY LASER
ID9763	MULTICHANNEL CAVITY LASER	GB	8827385.9	2 225 482			MULTICHANNEL CAVITY LASER
ID9763	MULTICHANNEL CAVITY LASER	US	07/625,818	5,115,444			MULTICHANNEL CAVITY LASER
ID9774	INTEGRATED OPTICS ASYMMETRIC Y- COUPLER	GB	8902391.5	2 227 854	·		INTEGRATED OPTICS ASYMMETRIC Y-COUPLER
ID9806	OPTICAL FIBRE CABLE	us	07/544,678	5,082,380			OPTICAL FIBRE CABLE
ID9837	AERIAL OPTICAL FIBRE CABLE	US	07/596,381	5,050,960			AERIAL OPTICAL FIBRE CABLE
1D9856	SEMICONDUCTOR OPTICAL SOURCE	GB	8924725.8	2 237 654			SEMICONDUCTOR OPTICAL SOURCE
ID9870	RING LASER	FR	90309362.3	0 419 059			RING LASER
ID9870	RING LASER	GB	8921295.5	2 236 426			RING LASER
ID9870	RING LASER	DE	69003780.5	0 419 059			RING LASER
ID9870	RING LASER	JP	249922/1990	3004336	 		RING LASER
ID9870	RING LASER	US	07/583,590	5,056,096			RING LASER
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	FR	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	CA	2,013,849	2,013,849			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	B OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	DE	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
WO0068	B OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	EP	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO006	8 OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	US	07/363,006	4,934,774	1		OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE

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MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	US	07/501,990	5,035,916			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	GB	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0166	A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM AN OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER	US	08/710,775	5,703,980			A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM A OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	CA	2,209,548				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	EP	97111629.8				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	JP	9-185588				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	US	08/677,922	5,793,913	·		A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		09/079,480	6,158,901			A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	US	09/584,792	6,391,214			METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
RE1009	FIBER OPTIC COUPLER	CA	476,580	1,258,787			FIBER OPTIC COUPLER
RE1009	FIBER OPTIC COUPLER	US	07/442,878	4,950,046			FIBER OPTIC COUPLER
RE1037	OPTICAL SIGNAL MODULATORS	CA	507,411	1,257,923			OPTICAL SIGNAL MODULATORS
RE1037	OPTICAL SIGNAL MODULATORS	US	06/856,887	4,730,171			OPTICAL SIGNAL MODULATORS
RO1624	HERMETIC OPTICAL ATTENUATOR	us	06/233,500	4,695,125			HERMETIC OPTICAL ATTENUATOR

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No 42 RO1807	DIFFUSION EQUIPMENT	CA	416,834	1,204,986	DIFFUSION EQUIPMENT
RO1807	DIFFUSION EQUIPMENT	US	06/446,441	4,493,287	DIFFUSION EQUIPMENT
RO1809	A PLANAR NARROW- STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT	US	06/448,383	4,530,099	A PLANAR NARROW-STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT
RO1882	MELT DISPENSING LIQUID PHASE EPITAXY BOAT	CA	448,169	1,201,220	MELT DISPENSING LIQUID PHASE EPITAXY BOAT
RO1882	MELT DISPENSING LIQUID PHASE EPITAXY BOAT	US	06/583,985	4,574,730	MELT DISPENSING LIQUID PHASE EPITAXY BOAT
RO1903	METHOD FOR SCREENING LASER DIODES	CA	447,814	1,196,080	METHOD FOR SCREENING LASER DIODES
RO1903	METHOD FOR SCREENING LASER DIODES	US	06/582,956	4,489,477	METHOD FOR SCREENING LASER DIODES
RO1944	PHASED LINEAR LASER ARRAY	CA	465,981	1,238,707	PHASED LINEAR LASER ARRAY
RO1944	PHASED LINEAR LASER ARRAY	us	06/663,424	4,661,962	PHASED LINEAR LASER ARRAY
RO1961	ZINC DIFFUSION INTO INDIUM PHOSPHIDE	CA	495,084	1,290,656	ZINC DIFFUSION INTO INDIUM PHOSPHIDE
RO1961	ZINC DIFFUSION INTO INDIUM PHOSPHIDE	US	07/243,138	4,889,830	ZINC DIFFUSION INTO INDIUM PHOSPHIDE
RO1987	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE	CA	483,077	1,238,973	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE
RO1987	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE	US	06/673,644	4,660,207	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE
RO1994	A SURFACE EMITTING LASER	CA	474,029	1,238,971	A SURFACE EMITTING LASER
RO1994	A SURFACE EMITTING LASER	US	06/701,839	4,675,877	A SURFACE EMITTING LASER
RO2005	A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER	US	06/701,707	4,675,876	LASER
RO2005	A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER	GA	474,030	1,238,972	LASER
RO2268	AN INTERRUPTED LIQUI PHASE EPITAXY TECHNIQUE	D CA	562,885	1,293,179	EPITACT TECHNIQUE
RO2268	AN INTERRUPTED LIQUI PHASE EPITAXY TECHNIQUE	D US	07/179,834	4,859,628	AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE

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RO2314	MONOLITHIC INTEGRATION OF OPTOELECTRONIC AND ELECTRONIC DEVICES	US	07/176,120	4,847,665		MONOLITHIC INTEGRATION OF OPTOELECTRONIC AND ELECTRONIC DEVICES
RO2349	GROWTH OF SEMI- INSULATING INP BY LIQUID PHASE EPITAXY	US	07/201,155	4,849,373		GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY
RO2349	GROWTH OF SEMI- INSULATING INP BY LIQUID PHASE EPITAXY	CA	568,369	1,313,107		GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY
RO2461	OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION	US	07/369,883	4,969,712		OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION
RO2468	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE	CA	2,018,900	2,018,900		PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE
RO2468	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE	US	07/385,599	4,953,006		PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE
RO2564	LASER DIODE STRUCTURE	FR	91908207.3	0 530 212		LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	DE	91908207.3	691 07 845.9		LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	GВ	91908207.3	0 530 212		LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	US	07/522,015	4,989,214		LASER DIODE STRUCTURE
RO2579	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER	US	07/582,464	5,050,953		MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER
RO2579	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER	GB	91185124	2 248 968		MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER
RO2714	APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS	US	07/996,411	5,350,923		APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	DE	94915483.5	694 08 144.2		OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	FR	94915483.5	0 708 930		OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION

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02785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	GB	94915483.5	0 708 930		OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	JP	7-504252-95	2691638		OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
O2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	US	08/091,708	5,363,457		OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
	METHOD OF REDUCING THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES	US	08/118,273	5,345,459		METHOD OF REDUCING THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES
RO2799	GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION	US	08/170,074	5,452,318		GAIN COUPLED DFB LASER WIT INDEX COUPLING COMPENSATION
RO2809	METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES	US	08/158,545	5,586,207		METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBER TO THE PACKAGED DEVICES
RO2817	CIRCULAR GRATING LASERS	US	08/158,543	5,448,581		CIRCULAR GRATING LASERS
RO2875	CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER	US	08/450,841	5,524,076	•	CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATO USING NON EQUAL POWER SPLITTING
RO2879	SPLITTING SEMICONDUCTOR LASEF STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE		08/242,653	5,483,547		SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE
RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	GB	9513146.2	2 302 738		SEMICONDUCTOR MODULATO WITH A 2-2 SHIFT
RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	JP	8-188293			SEMICONDUCTOR MODULATO WITH A 2-2 SHIFT
RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	CA 2	2,176,099	2,176,099		SEMICONDUCTOR MODULATO WITH A SHIFT

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RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	US	08/612,555	5,694,504			SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT
RO2969	METHOD OF ETCHING PATTERNS IN III-V MATERIAL WITH ACCURATE DEPTH CONTROL	US	08/450,839	5,567,659			METHOD OF ETCHING PATTERNS IN III-V MATERIAL WITH ACCURATE DEPTH CONTROL
RO2974	MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY	US	08/413,555	5,536,085			MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	CA	2,209,455				COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	EP	97304743.4				COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	JР	9-174942				COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO2999	COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS	US	08/675,757	5,799,119			COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS
RO3007		US	08/728,991	6,028,875			BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKI G LAYER ,
RO3015	THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS	GB	9700985.6	2 309 335			THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3015	THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS	JP	9-009795				THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3015	THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS	us	08/977,371	5,960,014			THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3066	LASER DIODE AND METHOD OF FABRICATION THEREOF	US	09/093,399	6,151,347			LASER DIODE AND METHOD OF FABRICATION THEREOF

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No RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	CA	2,220,240	2,220,240			ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	ΕP	97308615.0				CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	US	08/745,168	5,778,113			CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	บร	09/057,602	5,991,471			CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3092	POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE	US	08/686,355	5,777,793			POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	CA	2,209,558				WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	EP	97111630.6	0 818 859	Nat'l Phase Filed		WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	US	08/680,284	5,825,792			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	JP	9-186204				WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139		GB	97111630.6	0 818 859			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	DE	97111630.6	697 11 126.1			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS WAVELENGTH MONITORING AND
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	FR	97111630.6	0 818 859			CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS

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	TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE	EP	98307439.4				TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
	TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE	JP	10-264323				TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
	TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE	US	08/933,529	5,936,994			TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
RO3479	DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION	US	08/953,015	6,026,110			DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	EΡ	98310111.4				SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	JР	10-366380				SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	US	08/998,071	6,104,739			SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3746	ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION	US	08/994,453	5,869,398			ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	wo	PCT/CA99/01067			ï	A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	CA	2,310,604				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	EP	99973441.1				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	JP	2000-588867				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER

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RO4144	COMPACT PROGRAMMABLE MATRIX OF STRONGLY COMPLEX COUPLED DFB LASERS FOR WIDE AND CONTINUOUS SINGLE WAVELENGTH	US	09/209,860	6,201,824			STRONGLY COMPLEX COUPLED DFB LASERS SERIES
RO4324	CONTINUOUSLY TUNABLE HIGH REPETITION RATE SHORT PULSE GENERATION USING DUAL MODE HIGHLY GAIN-COUPLED DEB	US	09/213,088				GENERATION OF SHORT OPTICAL PULSES USING STRONGLY COMPLEX COUPLED DFB LASERS
RO4416	LASER DIODES VARIABLE OPTICAL ATTENUATOR	US	09/388,628	6,246,826			VARIABLE OPTICAL ATTENUATOR WITH PROFILED BLADE
RO4504	ACTIVE REFLECTION MODULATOR	US	09/409,036				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	wo	PCT/CA00/00856		Nat'l Phase Filed		COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	CA	2,351,381				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	EP	947728.2				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
ŖO4504	ACTIVE REFLECTION MODULATOR	JP	2001-527411				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM

		a seed	Meaning 1	Pelent No.	ទួលនាការទ
Disc.	solisciosure due a				SLOTTED MONOLITHIC OPTICAL WAVEGUIDES
10163ID	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES	CA	2,311,961		
10163ID	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES	EP	304657		PHASE ADJUSTER USING SLOTTED, CONCATENATED WAVEGUIDES AND THERMO- OPTIC OR ELECTRO-OPTIC INSERTS
10163ID	SLOTTED MONOLITHIC	us	09/346,320	6,424,755	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES
11550RO	FOR A MEMS OPTICAL	CA	2,355,450		HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH
11550RO	SWITCH HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH	US	09/672,703		HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH
12801AU	TOD ATOD	EP	96940631.3		FIBRE OPTIC CIRCULATOR
	A CONTRACTOR	US	08/942,601	6,014,475	FIBRE OPTIC CIRCULATOR
12801AU	OPTICAL FILTERING METHOD		2,318,674		OPTICAL FILTERING METHOD AND DEVICE
	AND DEVICE			0.400.704	OPTICAL FILTERING METHOD AND DEVICE
12802AU	OPTICAL FILTERING METHOD AND DEVICE	US	09/660,147	6,466,704	
12802AU	OPTICAL FILTERING METHOD AND DEVICE	wo	PCT/AU00/00735		OPTICAL FILTERING METHOD AND DEVICE
12803AU	THE PARTY OF MICH	CA	2,313,311		REFLECTIVE NON RECIPROCAL OPTICAL DEVICE
12803AL		EP	202289.5		REFLECTIVE NON RECIPROCAL OPTICAL DEVICE

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No.				30		REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE
12803AU	REFLECTIVE NON RECIPROCAL OPTICAL	US	09/345,027	6,263,131		REFLECTIVE NON-RECIPHOCAL OPTICAL DEVICE
12803AU	DEVICE REFLECTIVE NON RECIPROCAL OPTICAL	US	09/610,601	6,415,077		REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE
12804AU	DEVICE WAVELENGTH DEPENDENT	CA	10/129828		Nat'l Phase Filed	WAVELENGTH DEPENDENT ISOLATOR
12804AU	USOLATOR WAVELENGTH DEPENDENT	us	PCT/AU00/01380		Nat'l Phase Filed	WAVELENGTH DEPENDENT ISOLATOR
12804AU	ISOLATOR WAVELENGTH DEPENDENT ISOLATOR	wo	PCT/AU00/01380		Nat'l Phase Filed	WAVELENGTH DEPENDENT ISOLATOR
13240AU	POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE	US	09/736,095			POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE
14081ID	FIBRE OPTICAL COMPONENT	US	09/888,888			FIBRE OPTICAL COMPONENT
14669AU	VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE	US	10/218,267			VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE
15087ID	AN OPTICAL GRATING DEVICE	us	10/109,916			AN OPTICAL GRATING DEVICE
1D0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	DE	95308065.2	695 27 251.9		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	EP	95308065.2	0 713 109	Nat'l Phase Filed	WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	FR	95308065.2	0 713 109		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	GB	9521916.8	2 295 245		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	JP	293047/1995			WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	US	08/557,857	5,703,976		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0226	OPTICAL WAVEGUIDE GRATINGS	GB	9318670.8	2 281 787		OPTICAL WAVEGUIDE GRATINGS
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	DE	95308201.3	695 25 223.2		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	EP	95308201.3	0 713 110	Nat'l Phase Filed	OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	FR	95308201.3	0 713 110		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	GB	9523489.4	2 295 247		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	US	08/558,709	5,638,473		OPTICAL WAVEGUIDE GRATING FILTER
1D0309	BRAGG GRATINGS IN WAVEGUIDES	US	08/647,795	5,730,888		BRAGG GRATINGS IN WAVEGUIDES
ID0355		DE	96302352.8	696 22 778.9	-	OPTICAL NOTCH FILTER MANUFACTURE
ID0359			96302352.8	0 736 784	Nat'l Phase	OPTICAL NOTCH FILTER MANUFACTURE

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NO.			96302352.8	0 736 784		OPTICAL NOTCH FILTER MANUFACTURE
ID0355	ALL-FIBRE OPTICAL FILTER	FR	96302332.8	0 7 30 7 0 7		
ID0355	ALL-FIBRE OPTICAL FILTER	GB	96302352.B	0 736 784		OPTICAL NOTCH FILTER MANUFACTURE
ID0355	ALL-FIBRE OPTICAL FILTER	US	08/628,579	5,708,740		ALL-FIBRE OPTICAL FILTER
ID0421	PLANAR WAVEGUIDES	us	08/842,021	5,904,491		PLANAR WAVEGUIDES
ID0423	PLANAR WAVEGUIDE CLADDING	US	08/842,022	5,885,881		PLANAR WAVEGUIDE CLADDING
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	CA	2,241,189			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
1D0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	DE	97906822.8	697 09 330.1		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	EP	97906822.8	0 891 570	Nat'l Phase Filed	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	FR	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	GB	9605320.2	2 311 145		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	GB	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
1D0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	IT	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	JP	532348/1997			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	US	09/101,276			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	wo	PCT/GB97/00606		Nat'l Phase Filed	WAVEGUIDES TO PHOTODE/ECTOR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	CA	2,239,118			WAVEGUIDE PAIR WITH CLADDING
ID0449	WAVEGUIDE PAIR WITH CLADDING	DE	97900292	697 02 299.4	Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	EP	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	FR	97900292	0 873 531	Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	GB	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY

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ID0449	WAVEGUIDE PAIR WITH CLADDING	ΙΤ	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	JР	524974/1997			WAVEGUIDE PAIR WITH CLADDING
1D0449	WAVEGUIDE PAIR WITH CLADDING	US	09/091,257	6,044,192		WAVEGUIDE PAIR WITH CLADDING
1D0449	WAVEGUIDE PAIR WITH CLADDING	wo	PCT/GB97/00040		Nat'l Phase Filed	WAVEGUIDE PAIR WITH CLADDING
ID0509	MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.	CA	2,211,244			OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS
ID0509	MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.	GB	9715185.6	2 316 185		MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.
ID0509	MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.	JP	209343/97	-		MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.
ID0509	MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.	US	08/896,092	6,115,518		OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	CA	2,282,939			OPTICAL EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	DE	99306728.9	699 01 419.0		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	EP	99306728.9	1 009 078	Nat'l Phase Filed	OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	FR	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	GB	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	iΤ	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	US	09/209,387	6,321,000		OPTICAL EQUALIZER
ID8550	OPTICAL FIBRES	GB	8230675	2 129 152		OPTICAL FIBRES

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ID9170	BEAM SPLITTER/COMBERS	CA	500,513	1,288,267		BEAM SPLITTER/COMBERS
ID9170	BEAM SPLITTER/COMBERS	GB	8503506	2 170 920		BEAM SPLITTER/COMBERS
ID9170	BEAM SPLITTER/COMBERS	US	06/819,125	4,756,589		BEAM SPLITTER/COMBERS
ID9441	DIRECTIONAL COUPLER	DE	378 25 37.2	378 25 37.2		DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	FR	87302418.6	0 246 737		DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	GB	8612660	2 190 762		DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	JP	118687/87	2022576		DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	US	07/032,783	4,801,185		DIRECTIONAL COUPLER
ID9579	GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS	GB	8716382	2 207 254		GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS
ID9730	DOPED ELEMENTS	GB	8820848.3	2 222 400		DOPED ELEMENTS
ID9758	"OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING"	GB	8926061.6	2 238 396		"OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING"
RO2922	POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ON BIREFRINGENCE COMPENSATION	US	08/329,923	5,488,679		POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ONBIREFRINGENCE COMPENSATION